

A study on intermediate buffer layer of coated Fiber Bragg Grating cryogenic temperature sensors

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INSTITUTE OF TECHNICAL PHYSICS, CRYOGENICS





For Today's discussion



- **Motivation**
- FBG sensor and detection principle
- Selection of coating materials and methods
- Sensor training & calibration

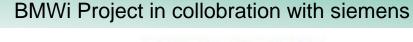
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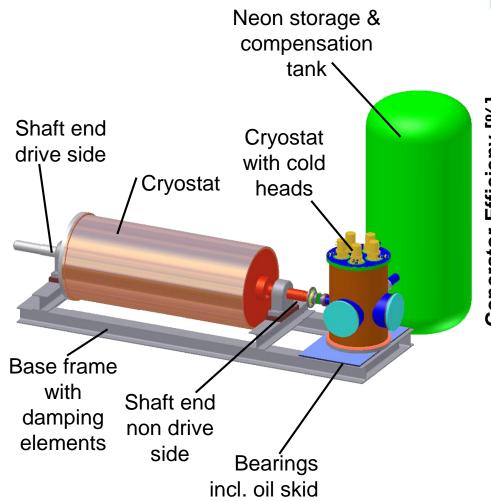
Results and Conclusion

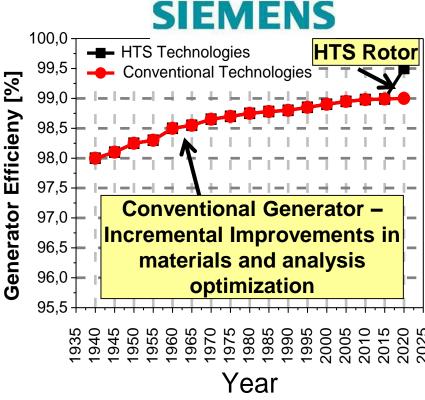
Grating cryogenic temperature sensors

TEMPERATURE:- ITER, KATRIN, HTS Generator





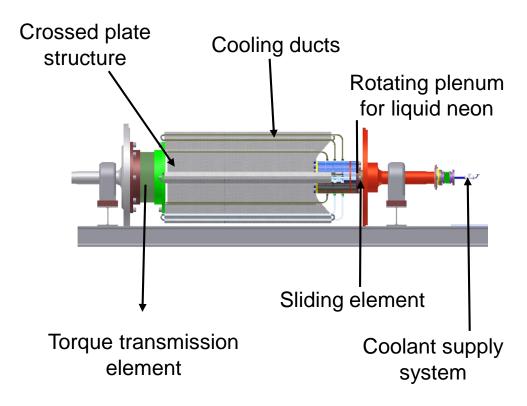




0.5% efficiency improvement can equal \$3.8 M for 900 MVA Generator

TEMPERATURE :- HTS Generator





Method 1 - operation with constant heating power

:- very good absolute measurement accuracy

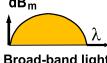
Method 2 - application of heat pulses

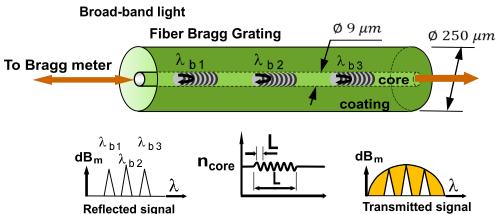
:- very high measurement resolutions

Fiber Bragg Gratings

FBG BASIC PRINCIPLE







$$\Delta \lambda_b = 2nL(\{1 - (n^2/2)[P_{12} - \nu(P_{11} + P_{12})]\}\varepsilon + [\alpha + (dn/dT)/n]\Delta T$$

Strain

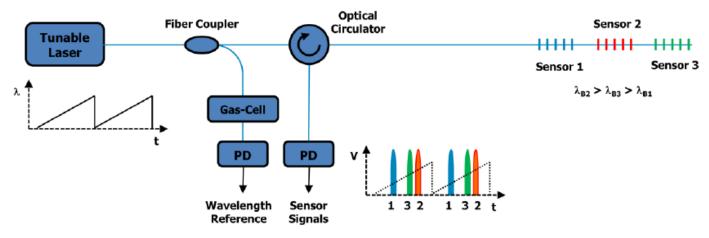
Temperature

FBG Sensors could be a possible choice

- ✓ Immunity to electromagnetic interference and losses along the optical path
 - ✓ High precision
 - ✓ Reduced dimensions
 - ✓ Durability
 - ✓ Easy to multiplex a large number of sensors along a single fiber
 - ✓ Corrosion resistance
 - ✓ Reducing the size of the cables

DETECTION METHOD





- Light from the laser was split into two by a 50/50 fibre coupler and optical circulator.
- Half of the light was guided to a FBG-sensor array while the other half to a National Institute of Standards and Technology traceable wavelength gas cell.
- By comparing time synchronized spectra from both gas-cell and FBGs it is possible to monitor absolute Bragg wavelength changes as small as 1 pm.
- A centroid method is then used to determine the central wavelength of the FBGs

MATERIAL SELECTION

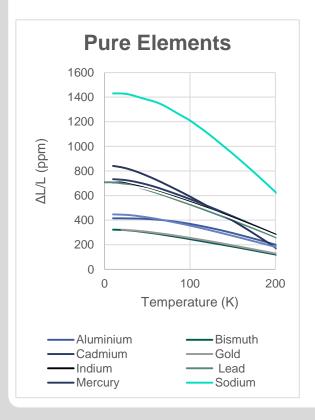
~ 120 K

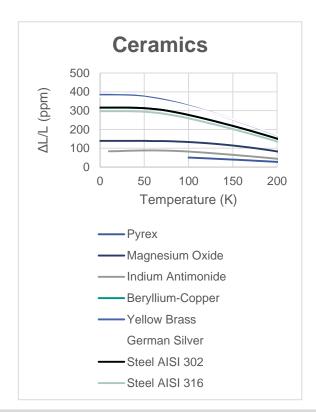


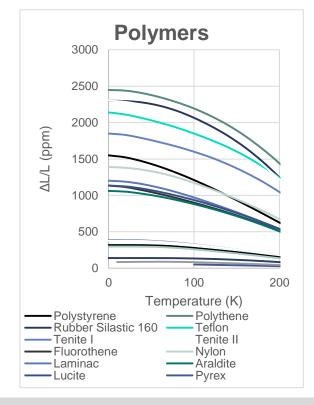
Coefficient of thermal expansion (CTE)

Young's modulus (E)

Adhesion



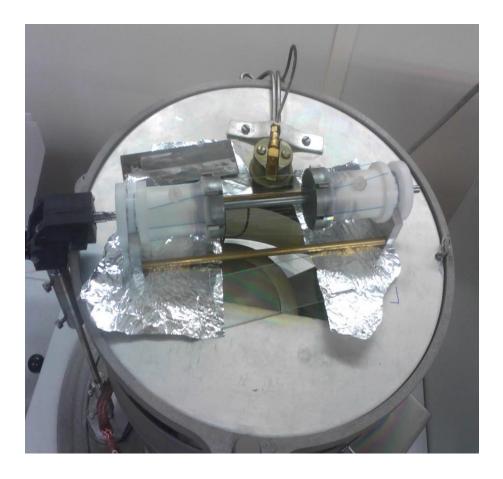




Electron beam deposition (EBD) - Primary coating

Buffer layer (Cr, Ti, Ni)





Rotating device at 6.6 rpm the chamber was put in 10⁻⁷ vacuum which took around 3 hours, then the deposition started at approximately 0.03 nm/s.

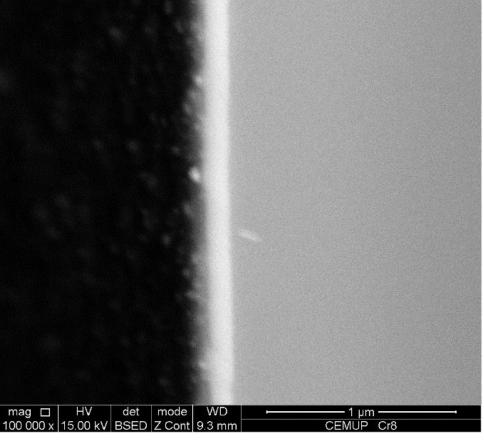
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Grating cryogenic temperature sensors

SEM analysis of an optical fiber

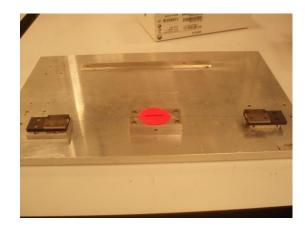


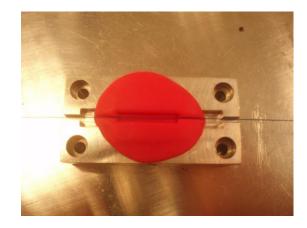




SECONDARY COATING - CASTING







CERNIT



15mm long and 2.5mm in diameter

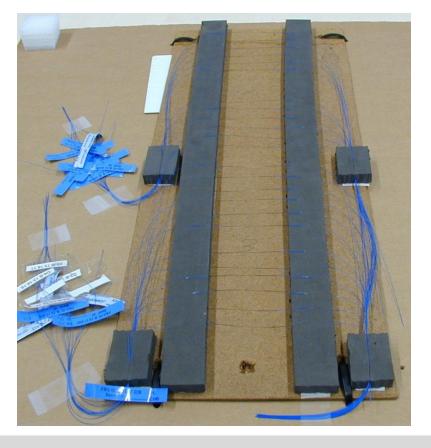
FABRICATION AND CALIBRATION



- Buffer layer : To ensure better Adhension :- Better performance

Series	Thin Film Coating	External Coating		
S1	100 nm Ti	In		
S2	100 nm Ti	Pb		
S3	200 nm Ti	In		
S4	200 nm Ti	Pb		
S5	100 nm Cr	In		
S6	100 nm Cr	Pb		
S7	200 nm Cr	In		
S8	200 nm Cr	Pb		
S9	50 nm Cr + 50 nm Ni	In		
S10	50 nm Cr + 50 nm Ni	Pb		
S11	150 nm Cr + 18.5 nm Ni	In		
S12	150 nm Cr + 18.5 nm Ni	Pb		

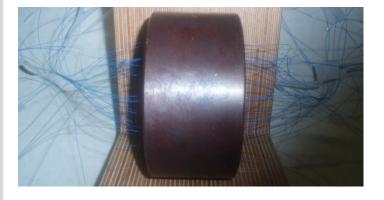


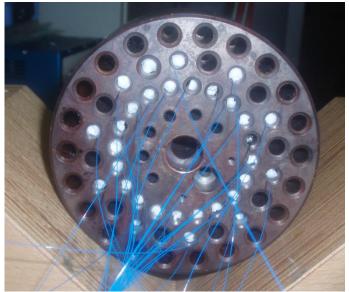


TRAINING

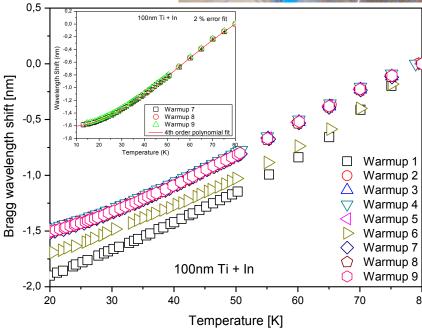


36 sensors



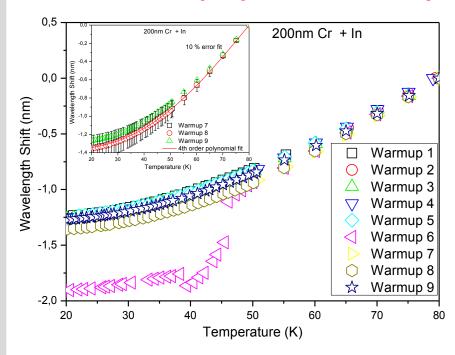


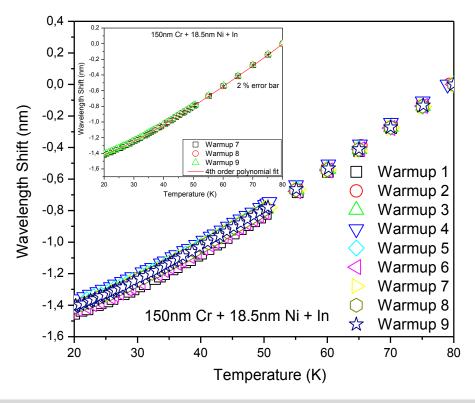




Chromium (Cr) and Nickel(Ni).







RESULTS



Temp.	Sensitivity nm/K											
	S1	S2	S3	S4	S5	S6	S7	S8	S9	S10	S11	S12
20K	0.013	0.012	0.010	0.013	0.005	Broken	0.013	0.007	0.014	0.013	0.013	Broken
30K	0.018	0.019	0.015	0.019	0.010		0.018	0.008	0.019	0.017	0.017	
40K	0.034	0.034	0.029	0.035	0.025		0.034	0.014	0.030	0.035	0.029	
70K	0.025	0.023	0.022	0.023	0.036		0.028	0.003	0.021	0.032	0.031	
Buffer	100	nmTi	200r	nmTi	100	nmCr	200ni	mCr	50nmCr N		150nm 18.5ni	

Conclusion



- Characteristics of FBG sensors with tin, chromium and chromium plus nickel buffer layers were studied.
- The sensors fabricated with different buffer layers were then coated with indium and lead secondary layers.
- The sensors subjected to temperature variation of 80–10 K initially showed a drift from their previous cycles, but it slowly gets stabilized and repeatable after 6th cycle.
- Sensor with a chromium buffer layer exhibits non repeatability due to the poor adhesion to indium secondary layer.
- The temperature sensitivity of the sensors were found to be 34 pm/ K @ 40 K and 13pm/ K at 20 K.
- With the detection unit of 1 pm resolution an temperature resolution of 0.29 K and 0.76 K respectively can be obtained.

Thank you !!!